

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA

Application No.: 10/587,254

Filed: June 1, 2007

For: OPTICAL SYSTEM, EXPOSURE SYSTEM,  
AND EXPOSURE METHOD



Group Art Unit: 2882

Examiner: C. KREUTZER

Docket No.: 128834

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination.

☒ Applicant(s) further request(s) entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 237252 in the amount of ☒ \$810.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated for this filing to Deposit Account No. 15-0461.

Respectfully submitted,

Mario A. Costantino  
Registration No. 33,565

Michelle K. Windom  
Registration No. 65,466

MAC:MQW/mjb

Date: May 6, 2011

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Alexandria, Virginia 22320-4850  
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry of this filing;  
Charge any fee due to our  
Deposit Account No. 15-0461

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